

L Number	Hits	Search Text	DB	Time stamp
1	6779	((250/492.1,216,306,307) or (359/245)).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/23 13:50
2	0	dielectric adj light adj barrier	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/23 13:52
3	0	dielectric\$4 adj light adj barrier	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/23 13:52
4	3055	dielectric\$4 near1 barrier	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/23 13:52
5	2	((dielectric\$4 near1 barrier) and (light adj barrier))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/23 13:53
6	1179	((dielectric\$4 near1 barrier) and ((conduct\$4 or metal\$4) near (surface or layer)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/23 13:54
7	927	((dielectric\$4 near1 barrier) and ((conduct\$4 or metal\$4) near (surface or layer))) and thickness	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/23 13:55
8	1	((((dielectric\$4 near1 barrier) and ((conduct\$4 or metal\$4) near (surface or layer))) and thickness) and (skin adj depth))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/23 13:57
9	1	((dielectric\$4 near1 barrier) and ((conduct\$4 or metal\$4) near (surface or layer))) and (skin adj depth)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/23 13:56
10	1	((dielectric\$4 near1 barrier) and ((conduct\$4 or metal\$4) near (surface or layer))) and (skin near depth)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/23 13:56
11	2	((((dielectric\$4 near1 barrier) and ((conduct\$4 or metal\$4) near (surface or layer))) and thickness) and (barrier near4 opaque))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/23 14:01
12	1	((((dielectric\$4 near1 barrier) and ((conduct\$4 or metal\$4) near (surface or layer))) and thickness) and (barrier near4 opaque)) and ((aperture or hole) with through with metal\$4 with barrier)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/23 14:01
13	1	((dielectric\$4 near1 barrier) and ((conduct\$4 or metal\$4) near (surface or layer))) and thickness) and (confin\$4 with excitation)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/23 14:02
14	1	((((dielectric\$4 near1 barrier) and ((conduct\$4 or metal\$4) near (surface or layer))) and thickness) and ((250/492.1,216,306,307) or (359/245)).CCLS.)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/06/23 14:02